ABSTRACT

A suction-and-holding face for a component in a is formed from a semiconductor ceramic so suction nozzle that the suction-and-holding face to be brought into direct component in suction and holding contact with the characteristics as semiconductor. Thus, detrimental effects due to occurrence of static electricity on the suction nozzle well as detrimental effects due to an electrical as conduction state between the suction nozzle and the component can be prevented from occurring.

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